

IFN

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of
Koichiro Kishima et al

SEP 29 2004

Application No.: 10/785,005

Art Unit: 2811

Filed: February 25, 2004

Conf. No. 9742

For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Submitted herewith on Form PTO-1449 or PTO/SB/08 is a listing of documents known to Applicant in order to comply with Applicant's duty of disclosure pursuant to 37 CFR 1.56. Applicant respectfully requests that the listed documents be considered by the Examiner and formally be made of record in the present application and that an initialed copy of Form PTO-1449 or PTO/SB/08 be returned in accordance with MPEP §609.

As provided in 37 CFR §1.98(d), copies of the documents are not being provided since they were previously cited by or submitted to the Patent Office in parent application Serial No. 10/390,768, filed March 19, 2003.

Concise Explanation of Relevancy of the Document

(Fill out if no English translation, partial translation or English abstract is available)

Any document having neither English translation nor English abstract relates to the subject matter of the above-identified application. English translation of the document is not readily available; however, the absence of such translations does not relieve the PTO from its duty to consider the submitted document (37 C.F.R. §1.98 and MPEP §609).

1. This Information Disclosure Statement is being filed within three months of the U.S. filing date or within three months from the date of entry of the national stage as set forth in 37 C.F.R. §1.491 in compliance with 37 C.F.R. §1.97(b), OR is being filed concurrent with filing of the Continued Prosecution Application (CPA) or the Request for Continued Examination (RCE). No fee is required (37 C.F.R. §1.97(b)).

Dated: September 29, 2004

Respectfully submitted,

By _____
Ronald P. Kahanen

Registration No.: 24,104
RADER, FISHMAN & GRAUER PLLC
1233 20th Street, N.W.
Suite 501
Washington, DC 20036
(202) 955-3750
Attorneys for Applicant



PTO/SB/08a/b (08-03)

Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/B/PTO				<i>Complete if Known</i>	
				Application Number	10/785,005
				Filing Date	February 25, 2004
				First Named Inventor	Shigeru Fujita
				Art Unit	2811
				Examiner Name	N/A
Sheet	1	of	1	Attorney Docket Number	SON-2612/DIV

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
AA	2002/0197818	12-02	Shih et al		
AB	6,387,761	05-02	Shih et al		
AC	6,339,246	01-02	Kizilyalli et al		
AD	6,482,694	11-02	Chittipeddi et al		
AE	2002/0043679	04-02	Miki et al		
AF	2002/0014666	02-02	Ohmi et al		
AG	2001/0016394	08-01	Koyanagi et al		
AH	6,048,769	04-00	Chau, Robert S.		
AI	6,538,278	03-03	Chau, Robert S.		
AJ	6,607,952	08-03	Yagishita et al		
AK	6,037,235	03-00	Narwankar et al		
AL	2003/0194853	10-03	Jeon, Joong		
AM	6,436,848	08-02	Ramkumar, Krishnaswamy		
AN	6,251,761	06-01	Rodder et al		
AO	6,407,435	06-02	Ma et al		
AP	6,693,004	02-04	Halliyal et al		
AQ	6,664,186	12-03	Callegari et al		
AR	2002/0137317	09-02	Kaushik et al		
AS	6,376,888	04-02	Tsunashima et al		
AT	6,586,349	07-03	Jeon et al		
AU	6,642,573	11-03	Halliyal et al		

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)			
BA					T ⁶

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
	CA				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	Date Considered
--------------------	-----------------